

TS01-1094

March 10, 2004

TO: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FROM: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, NY 12603

Subject: Serial #10/694,426
File Date: 10/27/03
Invr(s): Tsai, F.G., et al
Title: Method Of A Floating Pattern Loading System In Mask Dry-
Etching Critical Dimension Control

Enclosed are six sheets of Formal Drawings. Please enter these Drawings to replace the informal Drawings that were submitted with the Patent Application on 10/27/03. The Drawings should be filed under the Serial # 10/694,426. No new matter is added at this time. Thank you.

Stephen B. Ackerman
Reg. No. 37,761

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 10, 2004.

Signature
Stephen B. Ackerman, Reg. No 37,761

Date: 3/10/04

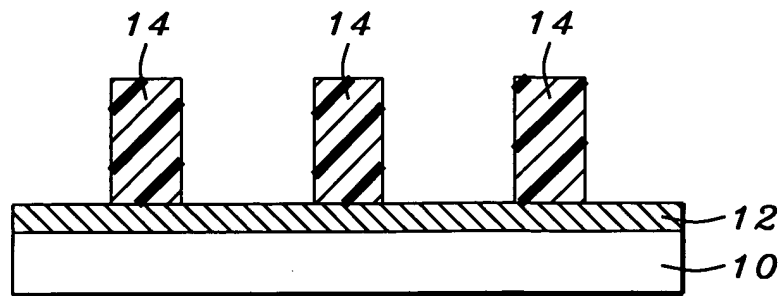


FIG. 1a - Prior Art

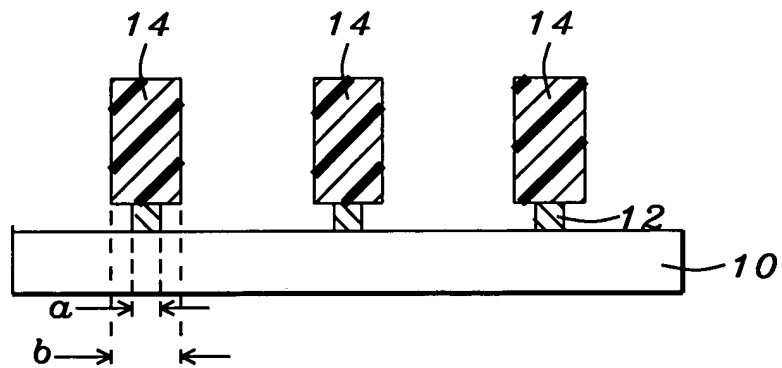


FIG. 1b - Prior Art

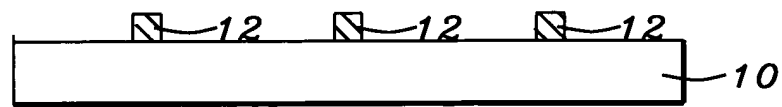


FIG. 1c - Prior Art

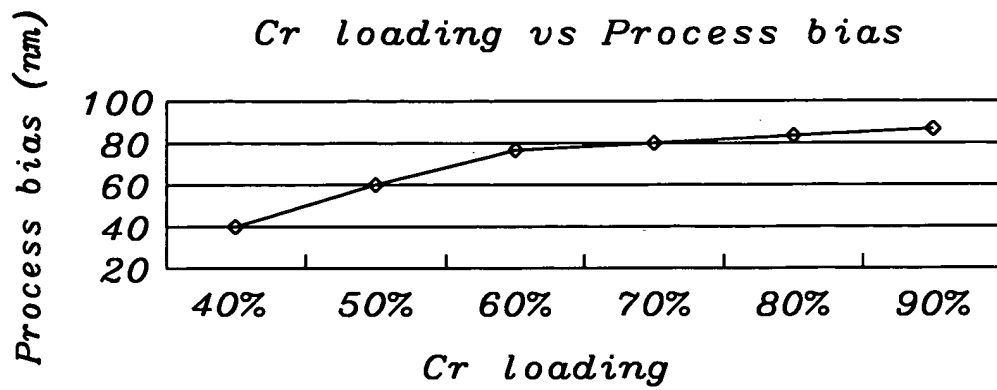


FIG. 2 - Prior Art

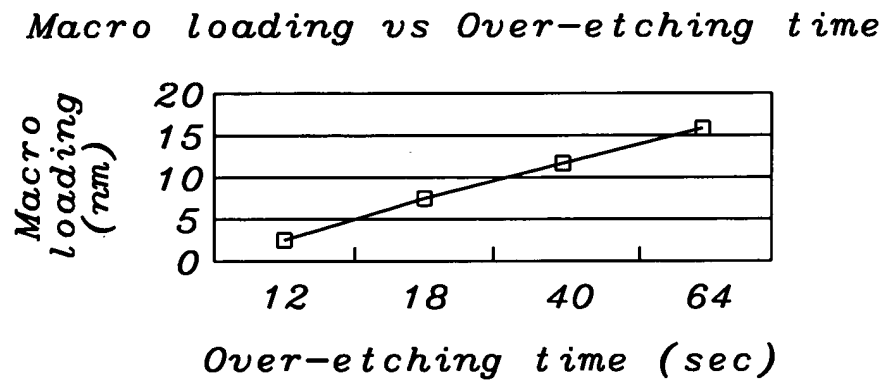


FIG. 3 - Prior Art

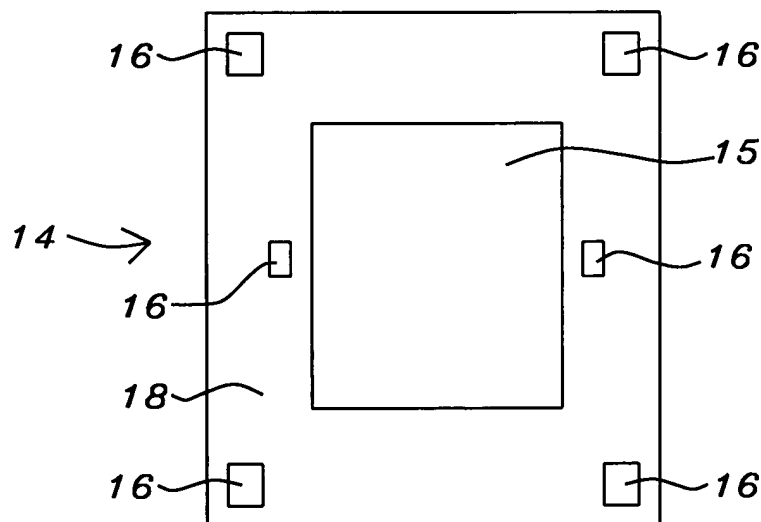


FIG. 4 - Prior Art

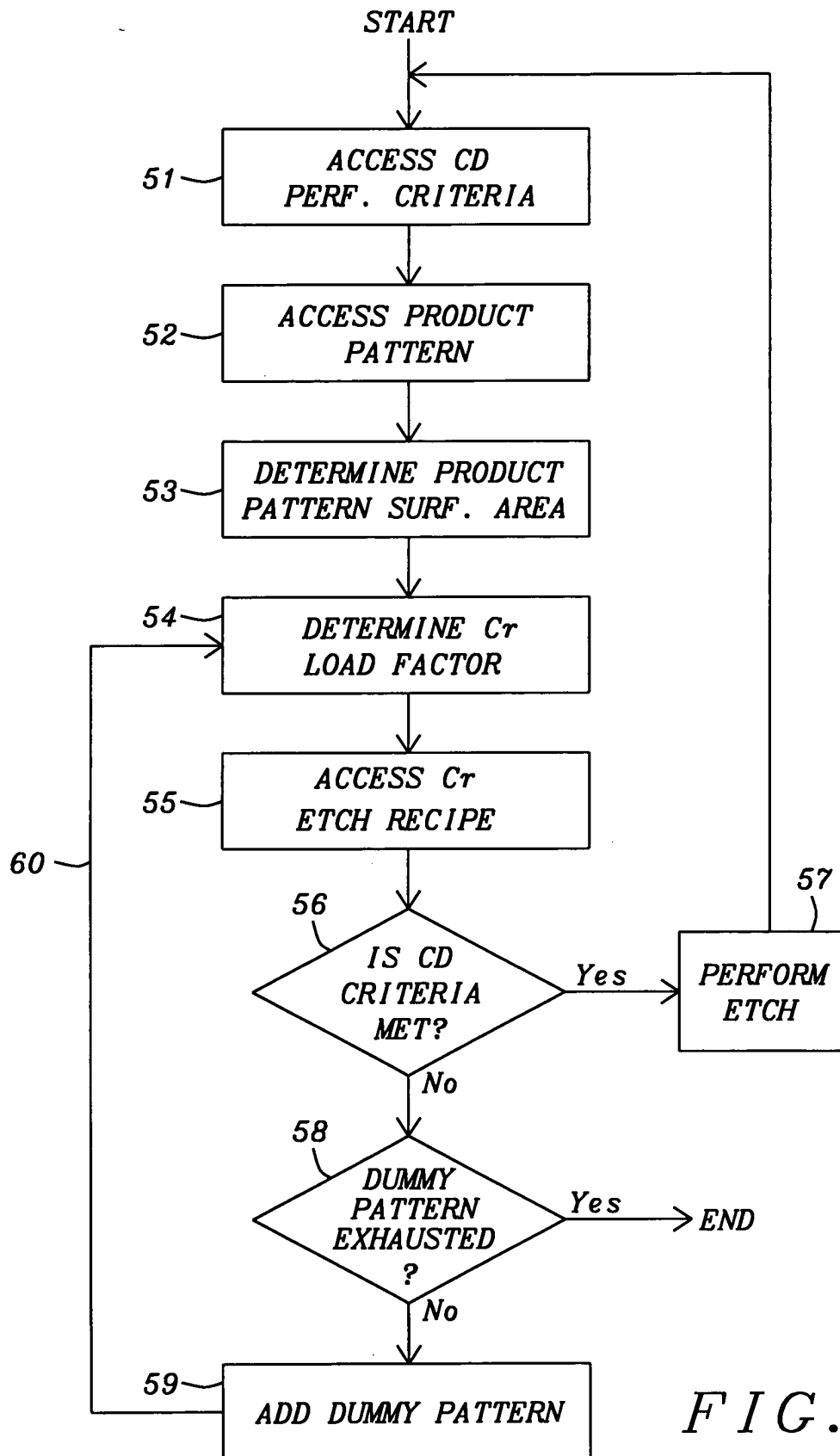


FIG. 5

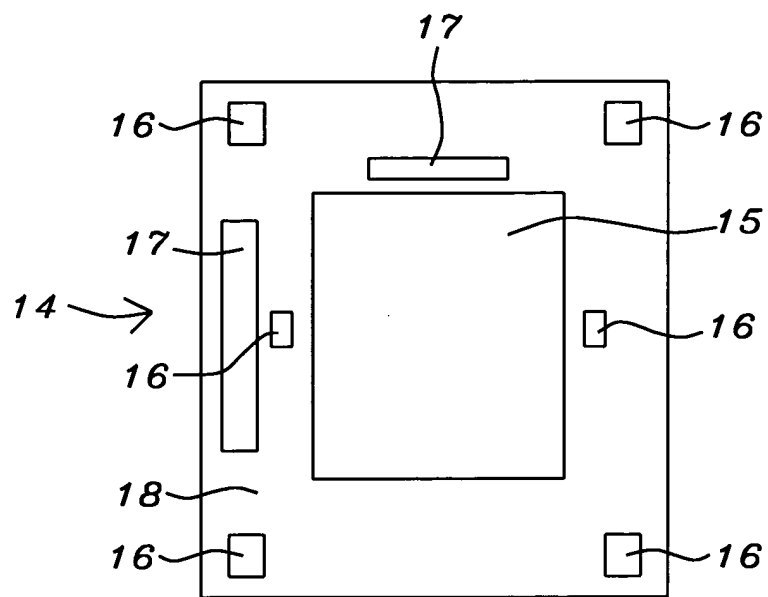


FIG. 6

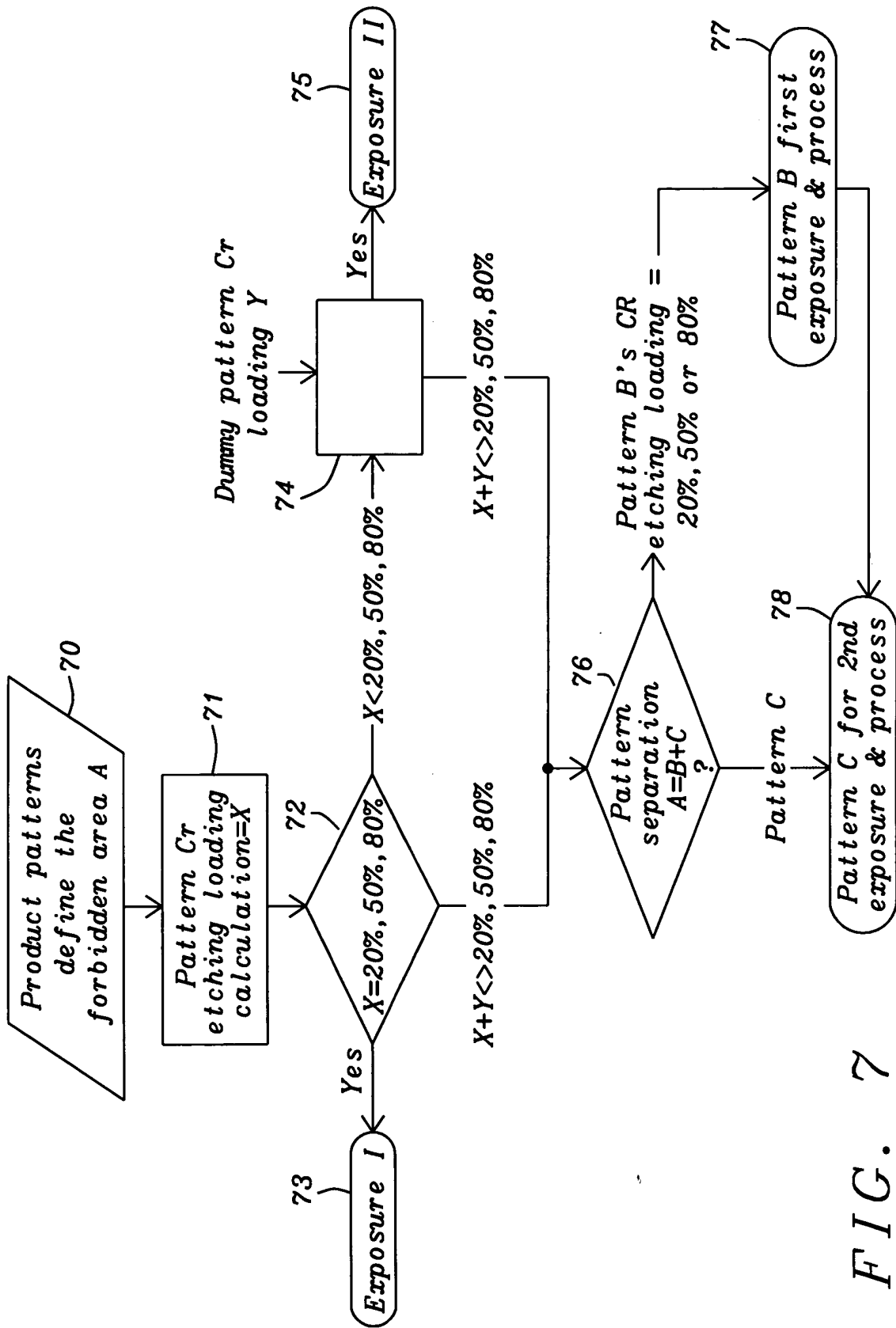


FIG. 7

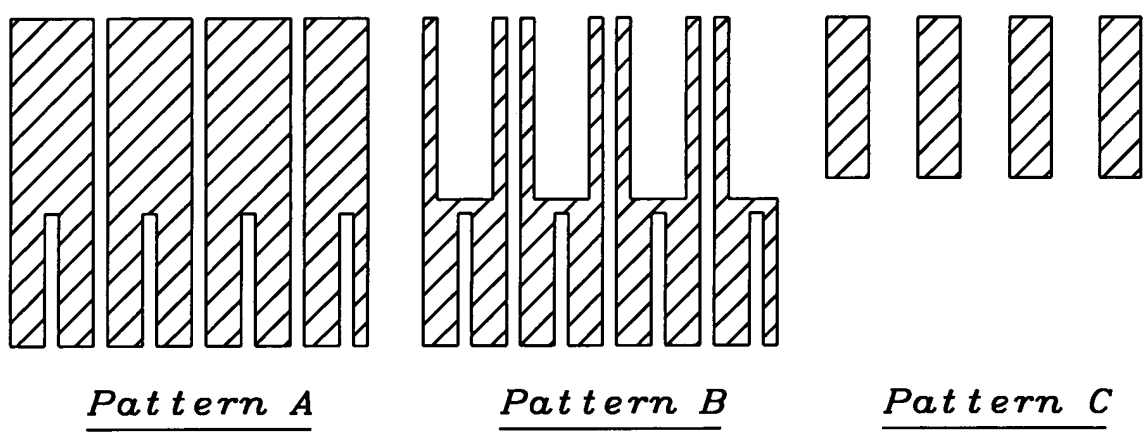


FIG. 8